IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: Shigeki ITO et al.

Serial Number: Not yet assigned

(§371 of international application No. PCT/JP2004/014282)

Filed: March 22, 2006

For: ANTISTATIC GLASS SUBSTRATE PRODUCTION METHOD AND ANTISTATIC GLASS SUBSTRATE PRODUCED BY THE METHOD

Attorney Docket Number: 062258
Customer Number: 38834

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P. O. Box 1450 Alexandria, VA 22313-1450 March 22, 2006

Sir:

In compliance with 37 C.F.R. §1.56, Applicants direct the attention of the Patent and Trademark Office to the documents listed on the attached PTO/SB/08. A copy of each non- U.S. document is enclosed herewith as well as an International Search Report mailed January 11, 2005.

If there are any fees due in connection with the filing of this paper, please charge Deposit Account No. <u>50-2866</u>.

Respectfully submitted,

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Enclosure: PTO/SB/08, Documents (5) & Int'l Search Report

10/573035 <u>| AP9 Rec'd PCT/PTO 22 MAR 2006</u>

Combined Form PTO/SB/08A&B

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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of

Compl	lete if Known		
Application Number	Not yet assigned		
Confirmation Number			
Filing Date	March 22, 2006		
First Named Inventor	Shigeki ITO et al.		
Art Unit			
Examiner Name			
Attorney Docket Number	062258		

U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No.1	Document Number		Publication Date	
		Number	Kind Code ² (if known)	MM-DD-YYYY	Name of Patentee or Applicant of Cited Document
		US			
		US			***
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FOREIGN PATENT DOCUMENTS							
Examiner Initials*	Cite No.1	Foreign Patent Document			Publication Date	Name of Patentee or	
		Country Code ³	Number ⁴	Kind Code ⁵ (if known)	MM-DD-YYYY	Applicant of Cited Document	Translation ⁶
	1	JP	2002-93768		3/29/2002	Matsushita Electric Works Ltd	Abstract
	2 %	JP	2-74901		3/14/1990	Fukui Pref Gov	Abstract
	3	JP	6-219868		8/9/1994	Bayer AG	Abstract
	4	JP	2002-72922	•	3/12/2002	Asahi Glass Co Ltd	Abstract
		 					
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		NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*					
	5	HARUHISA FUJII, "Control of Charge on Insulating Glass in Vacuum by Plasma Processing", IEEE Transaction on Dielectrics and Electrical Insulation 2002, Vol. 9, No. 2, pages 230-235			
	6	International Search Report of International Application PCT/JP2004/014282 mailed January 11, 2005			

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^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹Applicant's unique citation designation number (optional). ²See Kind Codes of USPTO Patent Documents at www.uspto.gov, MPEP 901.04 or in the comment box of this document. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST. 3). ⁴For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶ Applicant is to indicate here if English language Translation is attached.